



RCE
IFW JF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. 29936/39764

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a Request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the following application:

Application

| | |
|------------------------|--|
| Application Serial No: | 10/720,457 |
| Filed on: | November 24, 2003 |
| Inventor: | Cha Deok Dong |
| Title: | Method for Forming Device Isolation Film in Semiconductor Device |
| Art Unit: | 2822 |
| Examiner: | M. M. Trinh |
| Attorney Docket No.: | 29936/39764 |

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this Request for Continued Examination (RCE) is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, Mail Stop RCE, P.O. Box 1450, Alexandria, VA 22313-1450, on January 16, 2007.

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790.00 OP

James P. Zeller

1. **Submission required under 37 C.F.R. §1.114**

a. Previously submitted

i. Please consider the arguments and enter the amendments to the claims in the Amendment After Final Rejection filed December 18, 2006.

2. **Fees**

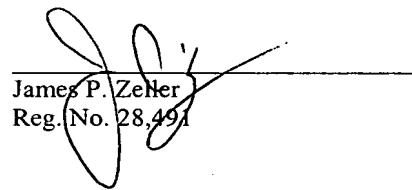
A check in the amount of \$790.00 for the filing fee is enclosed.

Please direct all future communications to James P. Zeller, at the address below.

Respectfully submitted,

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By:


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January 16, 2007